



FORM PTO-1449 (Modified)	Attorney Docket No.: 103-1	Application No.: 09/577,238
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Applicant: HO, Ying-Wai et al.	
	Filing Date: May 23, 2000	Group:

Reference Designation	U.S. PATENT DOCUMENTS	Page 1
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Examiner Initial	Document No.	Date	Name	Class	Sub-class	Filing Date (If Appropriate)
<u>CD</u> AA	4,866,652	09/1989	Chu et al.	364	748	
<u>CD</u> BB	5,159,665	10/1992	Priem et al.	395	134	
<u>CD</u> CC	5,206,823	04/1993	Hesson	364	748	
<u>CD</u> DD	5,220,524	06/1993	Hesson	708	502	
<u>CD</u> EE	5,257,216	10/1993	Sweedler	364	748	
<u>CD</u> FF	5,278,949	01/1994	Thayer	395	126	
<u>CD</u> GG	5,341,321	08/1994	Karp et al.	364	748	
<u>CD</u> HG	5,420,966	05/1995	Silverbrook	395	122	
<u>CD</u> II	5,420,971	03/1994	Westerink et al.	395	133	
<u>CD</u> JJ	5,530,663	06/1996	Garcia et al.	364	748	
<u>CD</u> KK	5,847,979	12/1998	Wong et al.	364	748.06	
<u>CD</u> LL	5,880,983	03/1999	Elliott et al.	364	748.07	
<u>CD</u> MM	5,889,690	03/1999	Arakawa	364	748.07	
<u>CD</u> NN	5,892,698	04/1999	Naffziger	364	748.07	
<u>CD</u> OO	5,928,316	07/1999	Wong et al.	708	501	
<u>CD</u> PP	5,999,960	12/1999	Gerwig et al.	708	500	
<u>CD</u> QQ	6,169,554 B1	01/2001	Deering	345	434	
<u>CD</u> RR	6,175,370	01/2001	Kunimatsu	345	434	
<u>CD</u> SS	6,275,838	08/2001	Blomgren et al.	708	501	

FOREIGN PATENT DOCUMENTS						
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	Document No.	Date	Country	Class	Sub-class	Translation (Yes/No)
<u>CD</u>						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	
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<u>CD</u> CE	Higaki et al., Four-Way VLIW Geometry Processor for 3D Graphics Applications, 12/1/1999, pg. 39-47.
<u>CD</u> CF	Hughes, PL.I Programming, 1973, John Wiley & Sons, pp. 5, 15-16, 74-75, 188-189, 217, 411-416, 423-424, and 689-690.

EXAMINER <u>[Signature]</u>	DATE CONSIDERED <u>1/23/03</u>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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